



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Soon-Jong Jung

Group Art Unit: 1765

Serial No.: 10/620,589

Examiner: Unknown

Filed: July 17, 2003

Attorney Docket No. SEC.1055

For: PROCESS CHAMBER FOR MANUFACTURING A SEMICONDUCTOR DEVICE

REQUEST FOR CORRECTED FILING RECEIPT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Application Number
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Attached is a copy of the official filing receipt from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.

Please correct the following data as follows:

Title:

Process chamber for manufacturing a **semiconductor** device

Respectfully submitted,

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Dated: January 26, 2004



UNITED STATES PATENT AND TRADEMARK OFFICE

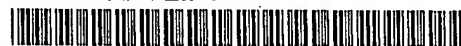


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/620,589	07/17/2003	1765	750	SEC.1055	1	5	1

CONFIRMATION NO. 9298

FILING RECEIPT



OC000000011607884

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Date Mailed: 01/05/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

Soon-Jong Jung, Suwon-City, KOREA, REPUBLIC OF;

Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2002-45912 08/02/2002

If Required, Foreign Filing License Granted: 01/02/2004

Projected Publication Date: 04/15/2004

Non-Publication Request: No

Early Publication Request: No

Title

Process chamber for manufacturing a semiconductor device
 Semiconductor

Preliminary Class

438